

<b>TLC Session 1: Precision Design Wednesday Nov 5, 2025 1:45-4:00 PM</b>		<b>Session Chairs: Leon Chao Kumar Arumugam</b>
<b>PDI</b>	Chao	Session Intro
<b>PDK</b>	de Jong	Session Keynote: Virtual Plan in Kinematic Couplings
<b>PD1</b>	Verdirame	A Survey of Passive Magnetic Bearings
<b>PD2</b>	Radgolchin	Novel Single-Axis Flexure Mechanism With Large Range Of Motion And Minimal Bearing Stiffness Drop
<b>PD3</b>	Bulla	Ultraprecision Machine Design For Large Mirror Manufacturing
<b>PD4</b>	Aguirre	Ultraprecision Spindle Motorization With Frameless Slotted Motors

<b>TLC Session 2: Micro and Nano Technologies Thursday Nov 6, 2025 8:00-10:15 AM</b>		<b>Session Chairs: Michael Cullinan Robert Panas</b>
<b>MNI</b>	Cullinan	Session Intro
<b>MNK</b>	Winkler	Session Keynote: Comparing state-of-the-art 2PP to competing processes – a take on precision, accuracy and throughput
<b>MN1</b>	Tsuji	Solid-State Electrochemical Soft Imprint For Direct Copper Nanopatterning In Optoelectronic Applications
<b>MN2</b>	Gülçür	Precision Prototyping Micromoulds For Microfluidics Using Custom Uv-Led Photolithography
<b>MN3</b>	Panas	Packaging and Demonstration of the Lightfield Directing Array
<b>MN4</b>	Yu	Closed-Loop Two-Photon Lithography Based On A Single-Cavity Dual-Comb Laser

<b>TLC Session 3:</b> <b>Precision Manufacturing</b> <b>Thursday Nov 6, 2025 10:AM -2:10 PM</b>		<b>Session Chairs:</b> <b>Ping Guo</b> <b>Christopher Morgan</b>
<b>PMI</b>	Guo	Session Intro
<b>PMK</b>	Wenzel	Session Keynote: IL1200 & IL1600 Series Vertical, Large Scale Ultra-Precision Diamond Turning Machines
<b>PM1</b>	Dupont	New Aerostatic Hybrid Bearing Technology For Improved Overload And Tool Collision Safety
<b>PM2</b>	Wang	Optical Meta-grating for Snapshot Multi-spectral Imaging
<b>PM3</b>	Shantiaeezade	Low Frequency Feed Modulation for Tool Eccentricity Cancellation and Chatter Avoidance in Milling
<b>PM4</b>	Sohn	Enhanced Single Point Diamond Rastering

<b>TLC Session 4:</b> <b>Metrology Systems &amp; Characterization</b> <b>Thursday Nov 6, 2025 2:15-4:10 PM</b>		<b>Session Chairs:</b> <b>Brandon D. Chalifoux</b> <b>Steven Gillmer</b>
<b>MetI</b>	Chalifoux Gillmer	Session Intro
<b>MetK</b>	Köchert	Session Keynote: Deterministic thinking with a multi-wavelength interferometer
<b>Met1</b>	Arumugan	Classical metrology techniques applied to a tabletop Kibble balance
<b>Met2</b>	Cacace	Displacement interferometry for high-tilt applications
<b>Met3</b>	Liu	Simultaneous Lateral And Axial Displacement Detection Based On Moiré Fringes
<b>Met4</b>	Rhorer	Challenges in applying error budgets to dynamic material testing

<b>TLC Session 5:</b> <b>Controls and Mechatronics</b> <b>Friday, November 7, 2025 8:30-10:30 AM</b>		<b>Session Chairs:</b> <b>Burak Sencer</b> <b>Dave Trumper</b>
<b>CMI</b>	Sencer/Trumper	Session Intro
<b>CMK</b>	Pechgraber	Session Keynote: Decoupling Adaptation Of A 3-Dof Dual-Stage Positioning System For High-Precision Optical Inline Metrology
<b>CM1</b>	Beijen	Spatial Domain Repetitive Control With Application To A Peristaltic Pump
<b>CM2</b>	Kim	Electromagnetic Active Workpiece Holder for Tool-workpiece Relative Vibration Compensation
<b>CM3</b>	Yamaguchi	High Precision Machining Of Spiral Bevel Gears Using Adaptive Control
<b>CM4</b>	Ro	An Air Conditioning System for an Ultra-Precision Machine to Isolate Room Temperature Variation

<b>TLC Session 6:</b> <b>Applications</b> <b>Friday Nov 7, 2025 1:45-3:35 PM</b>		<b>Session Chairs:</b> <b>Eric Buice</b> <b>Jaime Berez</b>
<b>AI</b>	Buice	Session Intro
<b>AK</b>	Burge	Session Keynote: Establishing position of complex optical surfaces and mechanical features with micron accuracy - day in and day out
<b>A1</b>	Kalidoss	DARPA ZENITH Liquid Mirror Telescope Program – Overview of error
<b>A2</b>	Lavery	Error Budgeting Ultrafast Laser Stress Figuring
<b>A3</b>	Hager	Accuracy Enhancement for Optimization-based Structured Light Profilometry
<b>A4</b>	Looman	Qualification setup to determine measurement uncertainty of beam-steering interferometry